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CONFIRMATION NO. 1871

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APPLICANTS Akimitsu Hatta, Nankoku-shi, JAPAN; Hiroaki Yoshimura, Nankoku-shi, JAPAN; Keiichi Ishimoto, Kochi-shi, JAPAN; Hiroaki Kanakusa, Kami-gun, JAPAN; Shinichi Kawagoe, Nankoku-shi, JAPAN;					
** CONTINUING DATA ***** This application is a 371 of PCT/JP03/11317 09/04/2003					
** FOREIGN APPLICATIONS ***** JAPAN 2002-272473 09/19/2002 JAPAN 2002-345192 11/28/2002 JAPAN 2003-007772 01/16/2003					
Foreign Priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Allowance Verified and Acknowledged		STATE OR COUNTRY JAPAN	SHEETS DRAWING 4	TOTAL CLAIMS 10	INDEPENDENT CLAIMS 3
ADDRESS 22428					
TITLE Acicular silicon crystal and process for producing the same					
FILING FEE RECEIVED 900	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		